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10587592 - GAIU 1792

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Application Number	10587592
Filing Date	2006-07-28
First Named Inventor	Tomomi MEGURO et al.
Art Unit	1792
Examiner Name	Talbot, Brian
Attorney Docket Number	81844.0051

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	1	4638111		1987-01-20	Gay	
	2	5002796		1991-03-26	Nishida	Corresponds to DE 3916983

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	1	20050145972	A1	2005-07-07	Fukuda et al.	Corresponds to WO 03065462

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	1	3916983	DE	A1	1989-11-30	Canon Kabushiki Kaisha	Corresponds to US 5002796	<input checked="" type="checkbox"/>
	2	03065462	WO	A1	2003-08-07	Kaneka Corporation	Corresponds to US 20050145972	<input checked="" type="checkbox"/>

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	3	1775491	SU	A1	1992-11-15	Borislavskij	<input type="checkbox"/>
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	1	Lau et al. "Growth of epitaxial ZnO Thin Films by Organometallic Chemical Vapor Deposition" Journal of Electrochemical Society, Electrochemical Society, Manchester, News Hampshire, Vol. 127, No. 8, pp. 1843-1847, 1980 <b>No month available</b>	<input type="checkbox"/>
	2	Li et al. "Growth of High Quality ZnO Thin Films at Low Temperature on Si(100) Substrates by Plasma Enhanced Chemical Vapor Deposition" Journal of Vacuum Science and Technology: Part A AVS/AIP, Melville, Vol. 20, No. 1, 2002 <b>No month available</b>	<input type="checkbox"/>
	3	Haga et al. "ZnO Thin Films Prepared by Remote Plasma-Enhanced CVD Method" Journal of Crystal Growth, Amsterdam, NL, Vol. 214-215, pp. 77-80, 2000 <b>No month available</b>	<input type="checkbox"/>
	4	European Search Report for corresponding European application 05709393.2-2122 lists the references above	<input type="checkbox"/>

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